

Electronic Patent Application Fee Transmittal

Application Number:	10593830
Filing Date:	22-Sep-2006
Title of Invention:	PROBE APPARATUS, WAFER INSPECTING APPARATUS PROVIDED WITH THE PROBE APPARATUS AND WAFER INSPECTING METHOD

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Attorney Docket Number:	296431US2PCT

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Utility Appl issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300

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Extension-of-Time:				
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Total in USD (\$)				1740